



Image AF/1762

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Barry Lee-Mean Yang et al. : Examiner: Timothy Meeks
Serial No. 10/063,094 : Group Art Unit 1762
Filed: March 19, 2002 : Paper No. 7
For APPARATUS AND METHOD FOR
LARGE AREA CHEMICAL VAPOR
DEPOSITION USING MULTIPLE
EXPANDING THERMAL PLASMA
GENERATORS

RESPONSE TO FINAL OFFICE ACTION

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S I R:

In response to the Office Action mailed on November 14, 2003, please amend the above-referenced application as follows.

If any additional fees for the accompanying response are required, the Director is hereby authorized to charge any fees that may be required to Deposit Account 07-0868.

Amendments to the Claims begin on page 2 of this paper;

Remarks begin on page 5 of this paper; and